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Bib Data Sheet

CONFIRMATION NO. 5218

SERIAL NUMBER 09/997,484	FILING DATE 11/21/2001 RULE	CLASS 359	GROUP ART UNIT 2873	ATTORNEY DOCKET NO. S004-4470
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APPLICANTS

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** CONTINUING DATA *****

** FOREIGN APPLICATIONS *****

JAPAN 2000-355972 11/22/2000
JAPAN 2000-367560 12/01/2000
JAPAN 2000-373307 12/07/2000
JAPAN 2000-377253 12/12/2000
JAPAN 2000-377254 12/12/2000

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 12/17/2001

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 32	TOTAL CLAIMS 24	INDEPENDENT CLAIMS 3
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> met after allowance				
Verified and Acknowledged	Examiner's Signature	Initials		

ADDRESS

ADAMS & WILKS
50 Broadway, 31st Floor
New York, NY 10004

TITLE

Method of fabricating optical aperture and method of fabricating probe for near field light device

**FILING FEE
RECEIVED**
942

FEES: Authority has been given in Paper
No. _____ to charge/credit DEPOSIT ACCOUNT
No. _____ for following:

<input type="checkbox"/> All Fees
<input type="checkbox"/> 1.16 Fees (Filing)
<input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
<input type="checkbox"/> 1.18 Fees (Issue)
<input type="checkbox"/> Other _____